IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:

Hsu, et al.

Attorney Docket: TSM02-1205

Filed:

Herewith

Examiner:

TBD

Serial No.:

TBD

Art Unit:

TBD

For:

Process for Improving Dielectric Properties in Low-k Organosilicate Dielectric Material

Mail Stop: Patent Application Commissioner for Patents P. O. Box 1450

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MAILING CERTIFICATE UNDER 37 C.F.R. §1.8(a)

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Dear Sir:

The Applicant wishes to bring to the attention of the Patent and Trademark Office the information noted on the enclosed form PTO/SB/08A & 08B that may be considered material to the examination of the above-identified application.

No fee is due at this time, as this Information Disclosure Statement is being filed concurrently with the patent application.

Respectfully submitted,

Ira S. Matsil

Attorney for Applicant

Reg. No. 35,272

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PTO/SB/08A (02-03)

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Complete if Known Substitute for form 1449/PTO **Application Number** Filing Date Herewith INFORMATION DISCLOSURE Hsu, et al. First Named Inventor STATEMENT BY APPLICANT TBD **Art Unit** (use as many sheets as necessary) TBD **Examiner Name** TSM02-1205 of Attorney Docket Number Sheet

	U.S. PATENT DOCUMENTS							
Examiner Initials*	Cite No.1	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear			
		Number - Kind Code ² (if known)		Applicant of Cited Document				
	<u> </u>	US-6,346,490 B1	02-12-2002	Catabay, et al.				
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FOREIGN PATENT DOCUMENTS						
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		OTHER PRIOR ART NON PATENT LITERATURE DOCUMENTS	
Examiner	Cite	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue	T ²
Iuiliaiz.	No.	number(s), publisher, city and/or country where published.	Ì
		Yang, S., et al., "Processing and Characterization of Ultralow-Dielectric Constant Organosilicate," J. Vac. Sci. Technol. B, Vol. 19, No. 6 (Nov/Dec 2001) pp. 2155-2161.	
		Terry, J., et al., "Alkyl-terminated Si(111) Surfaces: A High-Resolution, Core Level Photoelectron Spectroscopy Study," Journal of Applied Physics, Vol. 85, No. 1 (January 1, 1999) pp. 213-221.	
		Chang, T.C., et al., "Eliminating Dielectric Degradation of Low-k Organosilicate Glass by Trimethylchlorosilane Treatment," J.Vac. Sci. Technol. B., Vol. 20, No. 4 (Jul/Aug 2002) pp. 1561-1566.	
		Chang, T.C., et al., "Trimethylchlorosilane Treatment of Ultralow Dielectric Constant Material After Photoresist Removal Processing," Journal Of The Electrochemical Society, Vol. 149, No. 10 (August 2002) pp. F145-F148.	
1 (a)		Mor, Y.S., et al., "Effective Repair to Ultra-Low-k Dielectric Material (k~2.0) by Hexamethidisilazane Treatment," J. Vac. Sci. Technol. B, Vol. 20, No. 4 (Jul/Aug 2002) pp. 1334-1338.	
anne y Mil 1964 e relieu na gui ^{al} d-du-luy-u-y-u-u-y- ^{pr} i		Chang, T.C., et al., "Recovering Dielectric Loss of Low Dielectric Constant Organic Siloxane During the Photoresist Removal Process," Journal Of The Electrochemical Society, Vol. 149, No. 8 (June 2002) pp. F81-F84.	
		Liu, P., et al., "Highly Reliable Chemical-Mechanical Polishing Process for Organic Low-k Methylsilsesquioxane," J. Vac. Sci. Technol. B, Vol. 19, No. 4 (Jul/Aug 2001) pp. 1212-1218.	
		WOLF, S., "Silicon Processing for the VLSI Era," Vol. 4, Lattice Press, Sunset Beach, California (2002) pp. 639-670.	

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